

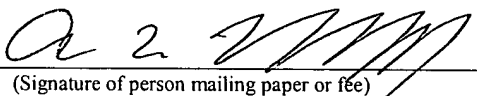
PATENT
37904-0033

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tohru Segawa et al.
U.S. serial no. : To be assigned
Filed : Herewith
For : SILICA GLASS JIG FOR SEMICONDUCTOR INDUSTRY
AND METHOD FOR PRODUCING SAME

EXPRESS MAIL MAILING LABEL NUMBER EU 969059932 US, Date of Deposit: September 15, 2003
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Andrew L. Tiajloff
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(Signature of person mailing paper or fee)

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above application as follows: